

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Petr VISCOR et al.

Application No.: 09/700,463



Filed: December 21, 2000

Docket No.: 107872

For: PLANAR ELECTRONIC EMITTER (PEE)

INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. References 7, 21, 24, 26 & 27 were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.
- 3. WO 94/14078 corresponds to European Patent No. 672257 which is cited in the specification.

Respectfully submitted,

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Form PTO-1449 (REV. 8-83)	US Dept. of Commerce PATENT & TRADEMARK OFFICE	ATTY DOCKET NO. 107872	APPLICATION NO. 09/700,463
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		O I P E FEB 13 2001 U. S. PATENT & TRADEMARK OFFICE JOHN	
		APPLICANTS Petr VISCOR et al.	
		FILING DATE December 21, 2000	

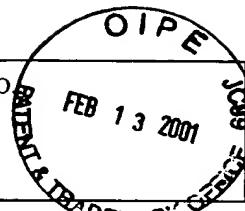
## U.S. PATENT DOCUMENTS

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
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EMJ	GB 1 303 659	01/17/1973	Great Britain		

EXAMINER <i>Elizabeth Yennell</i>	DATE CONSIDERED <i>4/14/03</i>
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	



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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)				
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EXAMINER <i>Elizabeth Hemmell</i>		DATE CONSIDERED <i>4/14/03</i>		
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